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INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No. 971003B	Serial No. Not yet assigned
	Applicants: Hideki MATSUMURA et al.	
	Filing Date: January 10, 2002	Group Art Unit: 1763 (Expected)

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
MM	AA	3,652,331	Yamazaki	3/1972	117	201	
MM	AB	4,237,150	Wiesmann	12/1980	427	74	
MM	AC	5,160,544	Garg et al.	11/1992	118	724	
MM	AD	5,366,919	Tanaka et al.	11/1994	437	52	
MM	AE	5,397,737	Mahan et al.	3/1995	437	101	
MM	AF	5,795,828	Endo et al.	8/1996	438	678	
MM	AG	5,840,600	Yamazaki et al.	11/1998	438	151	8/30/1995
MM	AH	5,149,375	Matsuyama	9/1992	118	719	
MM	AI	5,693,173	Colombo et al.	12/1997	156	345	12/21/1994
MM	AJ	5,183,529	Potter et al.	2/1993	156	613	
MM	AK	5,186,973	Garg et al.	2/1993	427	590	
MM	AL	5,209,812	Wu et al.	5/1993	156	613	
MM	AM	5,591,484	Poncelet et al.	1/1997	427	249	11/2/1995
MM	AN	5,054,421	Ito et al.	10/1991	118	723	
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OTHER DOCUMENTS

<u>MNB</u>	AR	S. Yamazaki et al. SILICON NITRIDE PRERARED BY THE SiH ₄ -NH ₃ REACTION WITH CATALYSIS. Japan Journal of Applied Physics, vol. 9, No. 12, dec. 1970, pp.1467-1477
<u>MNB</u>	AS	
Examiner <u>M. Kury</u>	Date Considered	11-25-03